



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Arnon Gat

Docket No: AGX-27-DIV

Serial No: 10/646,144

Group No: 2812

Confirmation No: 8736

Examiner: Unknown

Customer No: 22827

Filed: August 22, 2003

Date: January 21, 2004

For: Fast Heating And Cooling Apparatus For Semiconductor Wafers

**RELATED U.S. PATENT APPLICATION**

ASSISTANT COMMISSIONER FOR PATENTS

P.O. Box 1450

Alexandria, VA 22313-1450

The following commonly assigned U.S. Patent Application is being cited to the Examiner for review and consideration. Enclosed please find a copy of this application. Once the application has been reviewed, it is requested that the Examiner place his or her initial to the left of the identified patent on the list document to indicate that the specific patent application has been considered.

RELATED U.S. APPLICATIONS

<u>Examiner's Initial</u>	<u>Inventor</u>	<u>Serial Number</u>	<u>Filing Date</u>	<u>Title of Application</u>
_____	Shooshtarian, et al.	09/527,873	03/17/2000 (AGX-37)	Localized Heating And Cooling Of Substrates

- Not PTD-1449  
- no copy to be sent  
to applicant